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APR 1 1 2005

AMENDMENT TRANSMITTAL LETTER Under Small Entity Status					Attorney Docket No: INK-002	
Application Serial Number: 10/829,593		Filing Date: 04/21/2004		Examiner: Rachuba, Maurina T.		Group Art Unit: 3723
Invention: APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR WAFERS USING ONE OR MORE POLISHING SURFACES						
TO THE COMMISSIONER OF PATENTS AND TRADEMARKS: Transmitted herewith is an amendment in the above-identified application. The fee has been calculated as shown below.						
CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FÜR	NO. OF EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	113	MINUS	113	0	\$25	\$ 0.00
INDEP. CLAIMS	11	MINUS	l 1	0	\$100	\$ 0.00
Petition is hereby made under 37 CFR 1.136(a) to extend the time for response to the Office Action to and through, comprising an extension of the shortened statutory period of:  one month (\$60)three months (\$510) two months (\$225)four months (\$795)						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$ 0.00						
Small entity status of this application under 37 CFR 1.9 and 1.27 has been established by a verified statement previously submitted.  A verified statement to establish small entity status under 37 CFR 1.9 and 1.27 is enclosed.  A check in the amount of \$ is attached.  Charge \$ to Deposit Account  No additional fee is required.  A/11/2005  Date  Thomas H. Ham  Reg. No. 43,654						
CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8  I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being facsimile transmitted to the Patent and Trademark Office facsimile number (703) 872-9306 on April 11, 2005.  Number of Pages: 3 (including TRANSMITTAL LETTER)  Thomas H. Ham						

Attorney Docket No. INK-002

PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant(s): In Kwon Jeong

Group Art Unit: 3723

APR 1 1 2005

Scrial No. 10/829,593

Confirmation No. 6718

Filed: April 21, 2004

Examiner: Rachuba, Maurina T.

For:

APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR

WAFERS USING ONE OR MORE POLISHING SURFACES

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## RESPONSE TO OFFICE ACTION

## Sir/Madam:

In the Office Action dated March 11, 2005, the Examiner has asked the Applicant to elect from one of the following three groups:

Group I: Claims 7-9, 24-30, 53-67, 86-97 and 103-107, drawn to a method, classified in class 451, subclass 41.

Group II: Claims 1-6, 10-23, 31-52, 68-85 and 98-102, drawn to a combination, classified in class 451, subclass 011.

Group III: Claims 108-113, drawn to a subcombination, classified in class 451, subclass 402.

Furthermore, the Examiner has asked the Applicant to elect a single disclosed species from a list of alleged patentably distinct species.

CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being facsimile transmitted to the Palent and Trademark Office facsimile number (703) 872-9306 on April 11, 2005.

Number of Pages: 3 (including TRANSMITTAL LETTER)

Signed: //Lords N . Re

Typed Name: Thomas H. Ham

In response, Applicant elects without traverse Group II: Claims 1-6, 10-23, 31-52, 68-85 and 98-102, drawn to a combination, classified in class 451, subclass 011. Furthermore, Applicant elects without traverse "species 1, figure 1."

Applicant respectfully suggests that claims 1-6, 10-23, 31-52, 68-85 and 98-102 related to the elected Group II in the patent application are distinct over the prior art and that the application is in condition for allowance. Accordingly, a notice of allowance is carnestly solicited.

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Respectfully submitted,

In Kwon Jeong

Date: 4/11/2005

Date: 4/11/200

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